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## \*BIBDATASHEET\*

CONFIRMATION NO. 5741

Bib Data Sheet

<b>SERIAL NUMBER</b> 09/809,663	<b>FILING OR 371(c) DATE</b> 03/15/2001 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2823	<b>ATTORNEY DOCKET NO.</b> FIS920000396US1 / 130-000
<b>APPLICANTS</b> Mukesh V. Khare, White Plains, NY; Christopher P. D'Emic, Ossining, NY; Thomas T. Hwang, Wappingers Falls, NY; Paul C. Jamison, Hopewell Junction, NY; J. J. Quinlivan, Essex Junction, VT; Beth A. Ward, Essex Junction, VT;				
<b>** CONTINUING DATA *****</b> <i>none fil</i>				
<b>** FOREIGN APPLICATIONS *****</b> <i>none fil</i>				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 05/17/2001</b>				
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met <i>allowance</i> Verified and Acknowledged <i>Approved</i> Examiner's Signature Initials <i>fil</i>		<b>STATE OR COUNTRY</b> NY	<b>SHEETS DRAWING</b> 9	<b>TOTAL CLAIMS</b> 13 <b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> 32074				
<b>TITLE</b> Method for improved plasma nitridation of ultra thin gate dielectrics				
<b>FILING FEE RECEIVED</b> 710	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	